

TDM Photonic Network using Deposited Materials



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HPEC 2011



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Motivation for Silicon Photonics

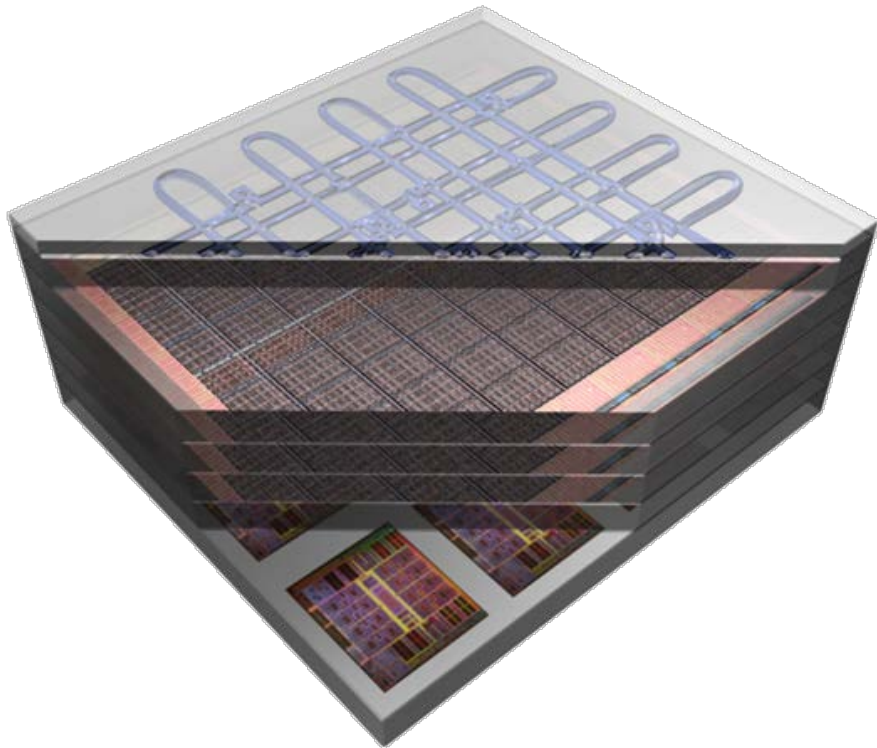


- Performance scaling becoming extremely difficult
 - Data movement cost increasingly expensive
 - On/off-chip communication bandwidth limited
- Photonics offers:
 - Higher bandwidth density
 - ✦ High datarate and parallel wavelengths
 - Low operating power
 - Low latency

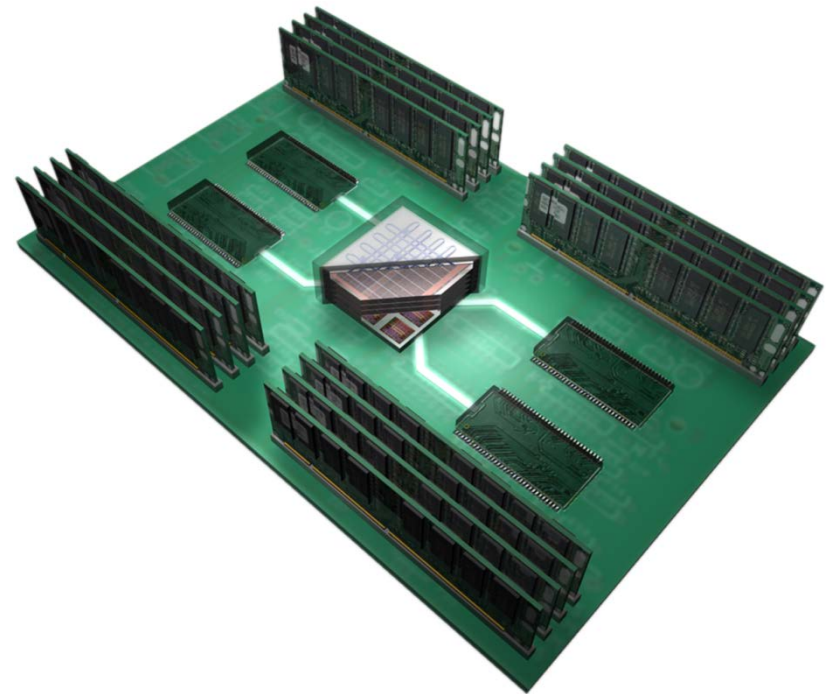
Target Architectures



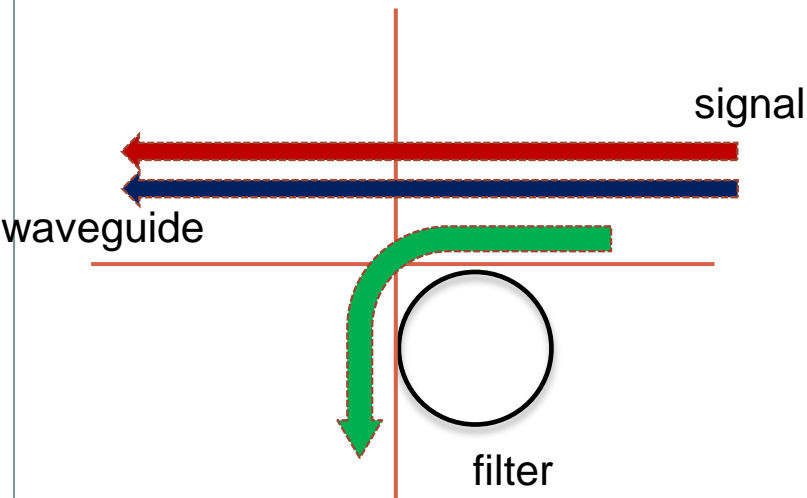
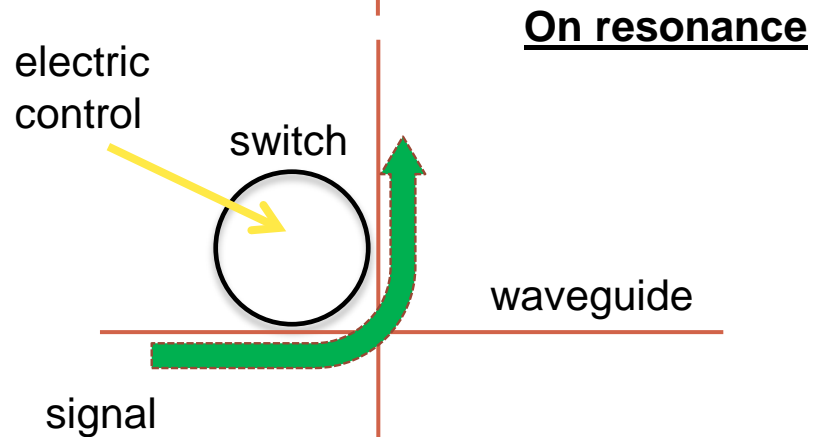
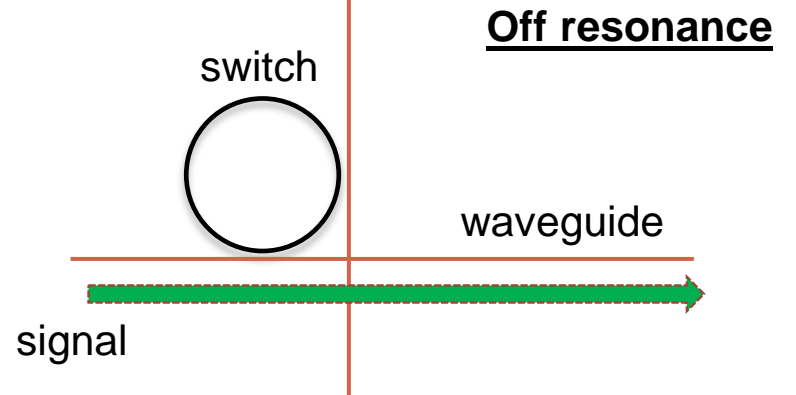
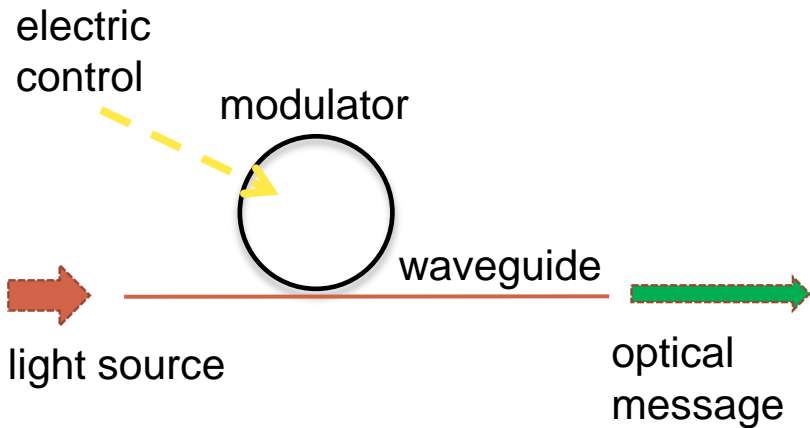
Optical interconnection network on stacked memory



Optical link to memory

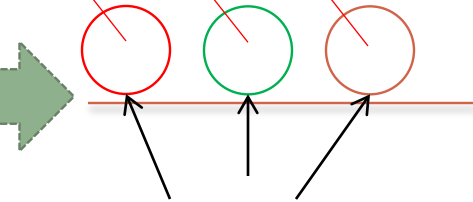


Ring Resonators



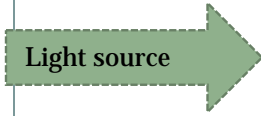
Photonic Communication

Electrical control

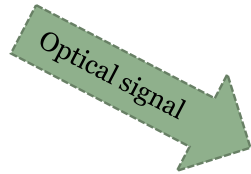


ring-resonator modulators

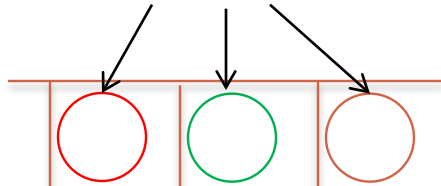
Light source



Optical signal



filters



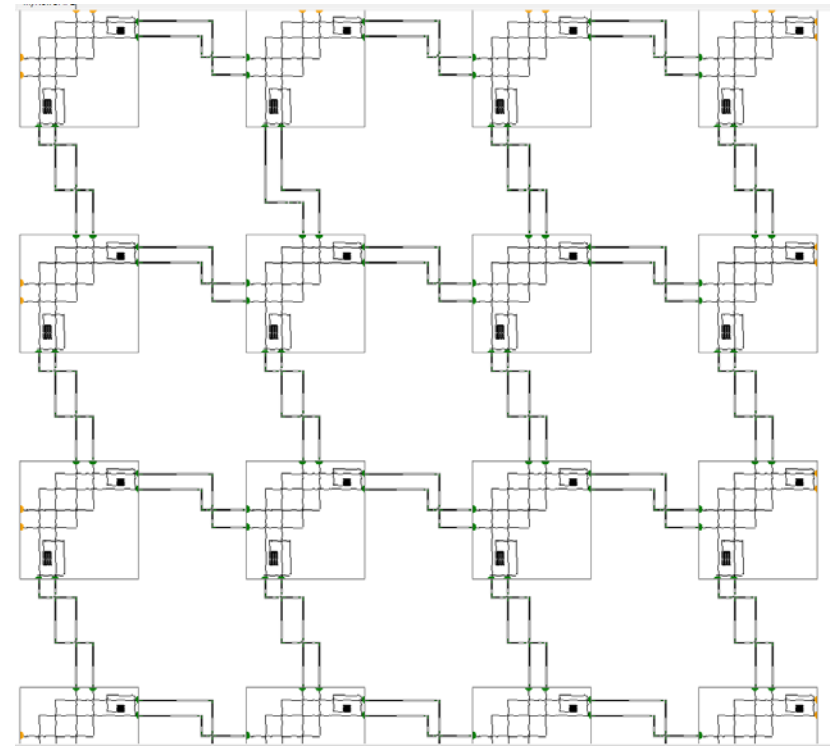
detectors



Optical signal

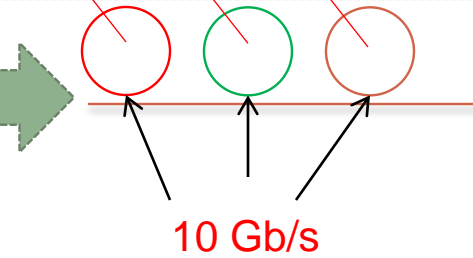


Photonic Network

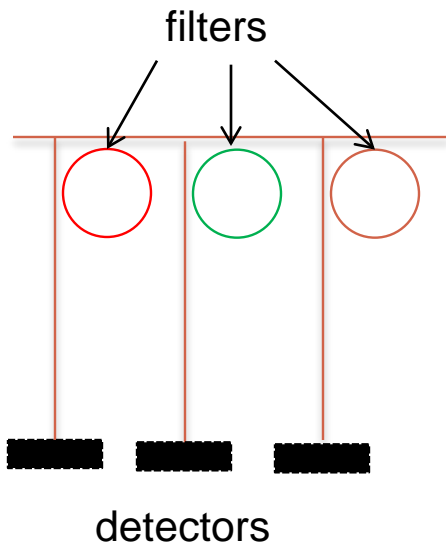


Photonic Communication

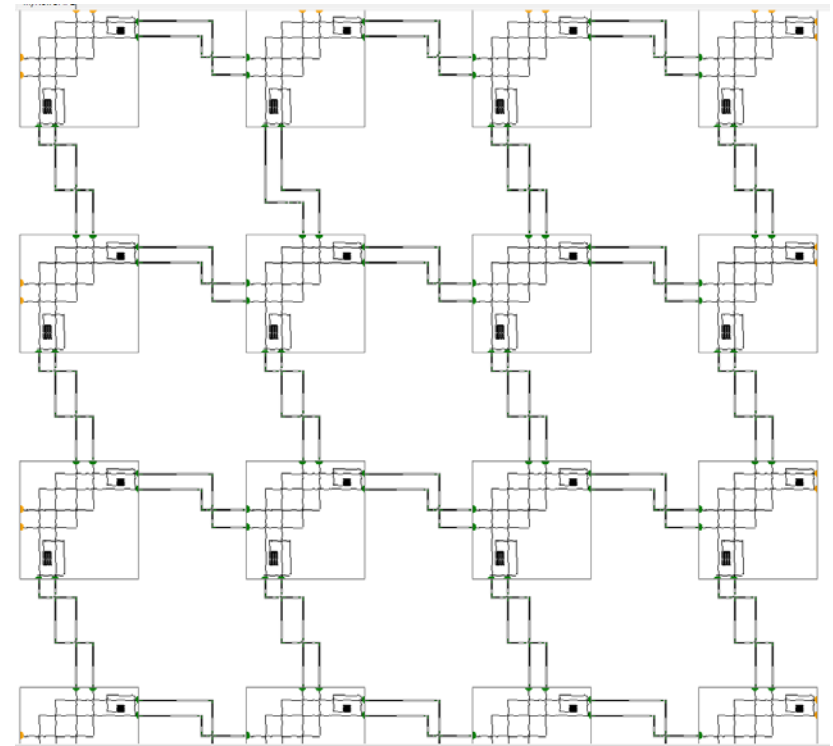
Electrical control



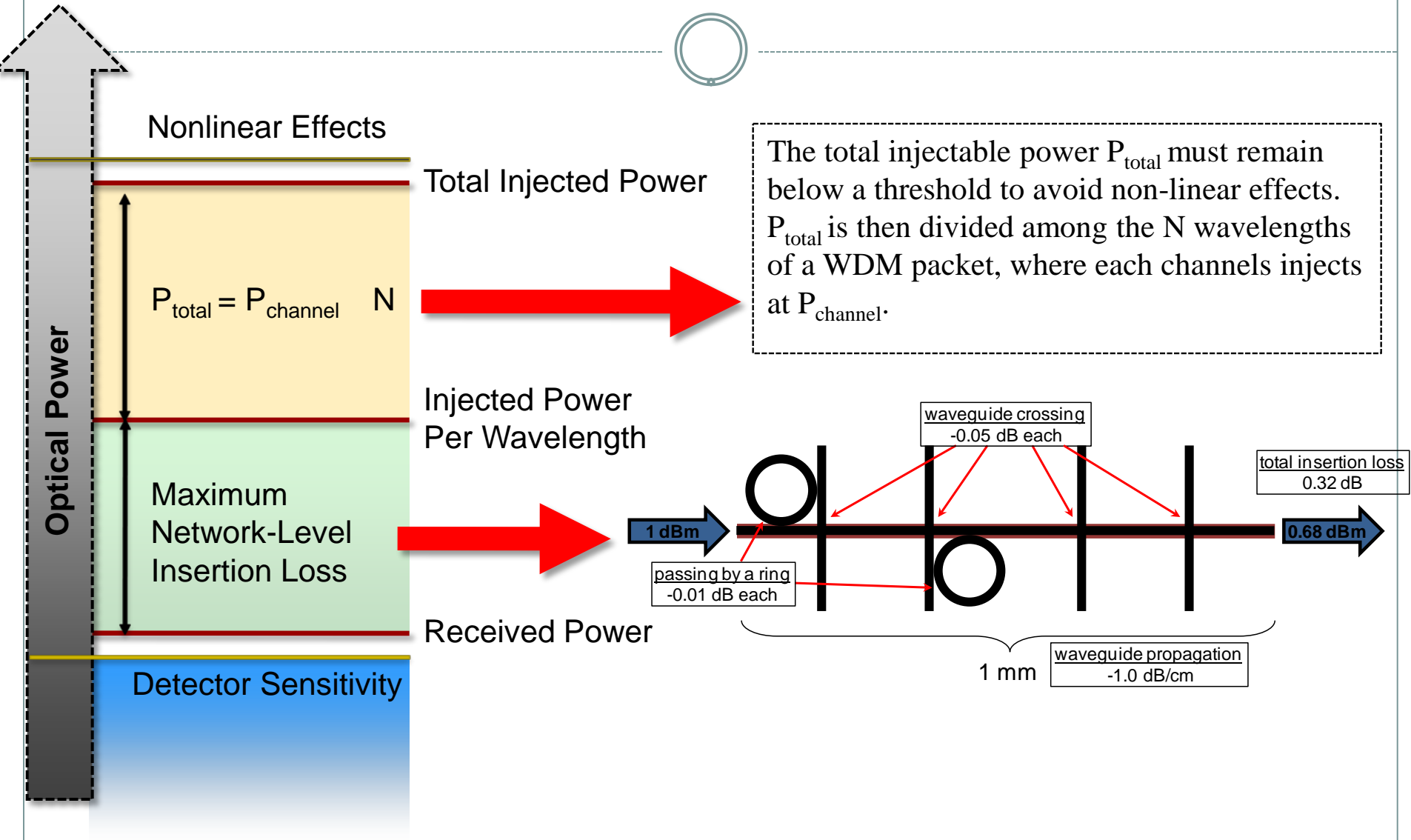
x 3 = 30 Gb/s aggregate bandwidth



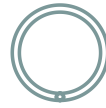
Photonic Network



Optical Power Budget



Silicon Photonics Technologies



Material	Propagation Loss
Crystalline Silicon	1.7 dB/cm [Xia et al. 2007]

- **Crystalline Silicon**
 - Best electrical and optical properties
 - Unable to deposit

Silicon Photonics Technologies



Material	Propagation Loss
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Polycrystalline Silicon	6.45 dB/cm [Fang et al. 2008]

- **Crystalline Silicon**
 - Best electrical and optical properties
 - Unable to deposit
- **Polycrystalline Silicon**
 - Can deposit
 - Very lossy

Silicon Photonics Technologies



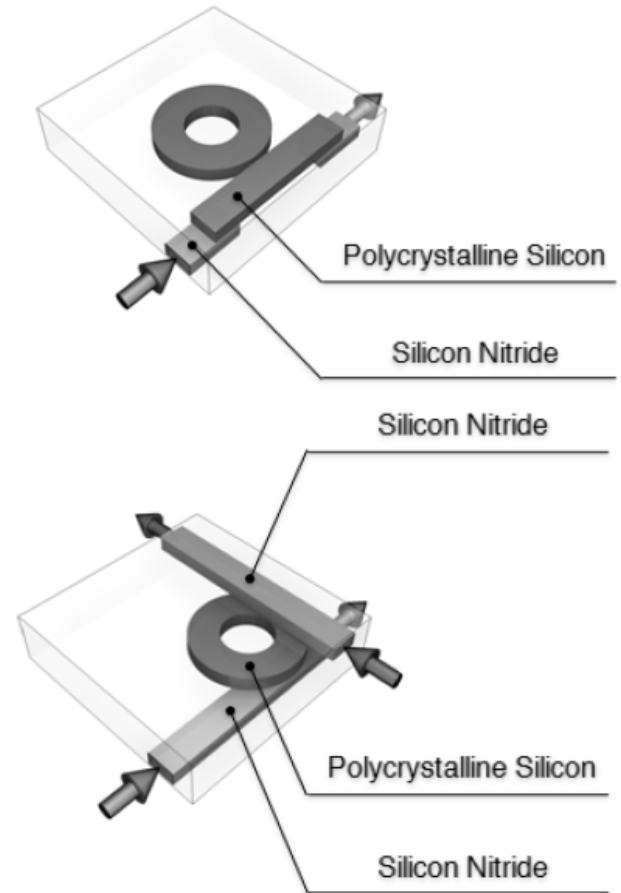
Material	Propagation Loss
Crystalline Silicon	1.7 dB/cm [Xia et al. 2007]
Polycrystalline Silicon	6.45 dB/cm [Fang et al. 2008]
Silicon Nitride	0.1 dB/cm [Shaw et al. 2005] [Gondarenko et al. 2009]

- **Crystalline Silicon**
 - Best electrical and optical properties
 - Unable to deposit
- **Polycrystalline Silicon**
 - Can deposit
 - Very lossy
- **Silicon Nitride**
 - Very low loss
 - Can deposit
 - Not useful active devices

Poly-Si / SiN Combination approach



- We can use silicon nitride and polycrystalline silicon in combination
 - SiN for non-active wave guides
 - Poly-Si for active devices (e.g. ring-resonator based switch)

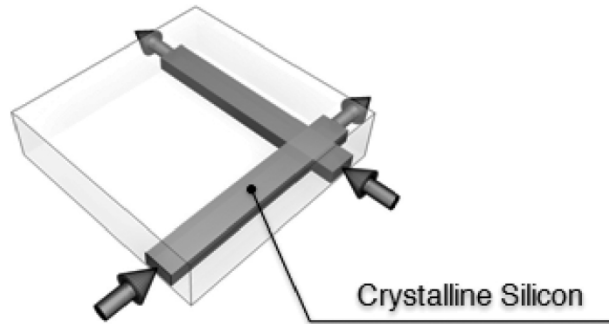


Designs for a layered modulator and switch

Poly-Si / SiN Combination approach



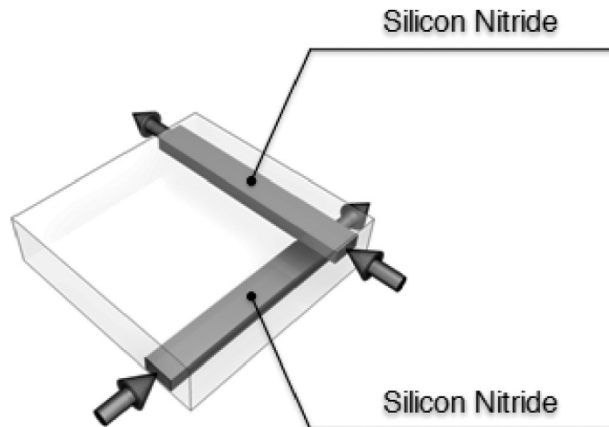
Single-Layer



Waveguide crossings eliminated

- Insertion loss, crosstalk both incurred heavily in waveguide crossings

3D-Integrated

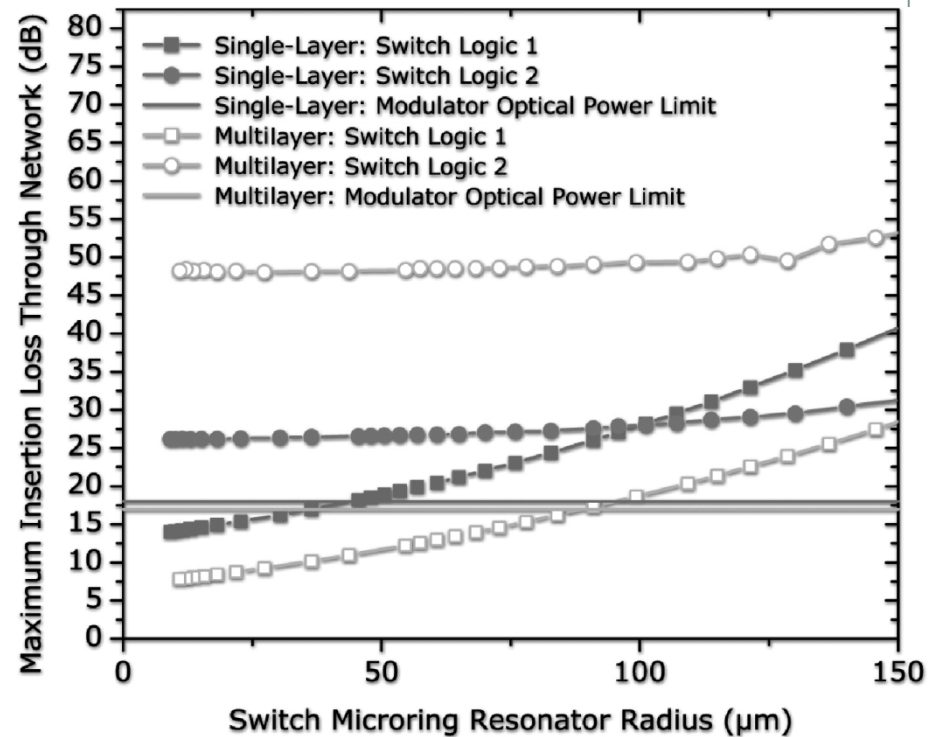
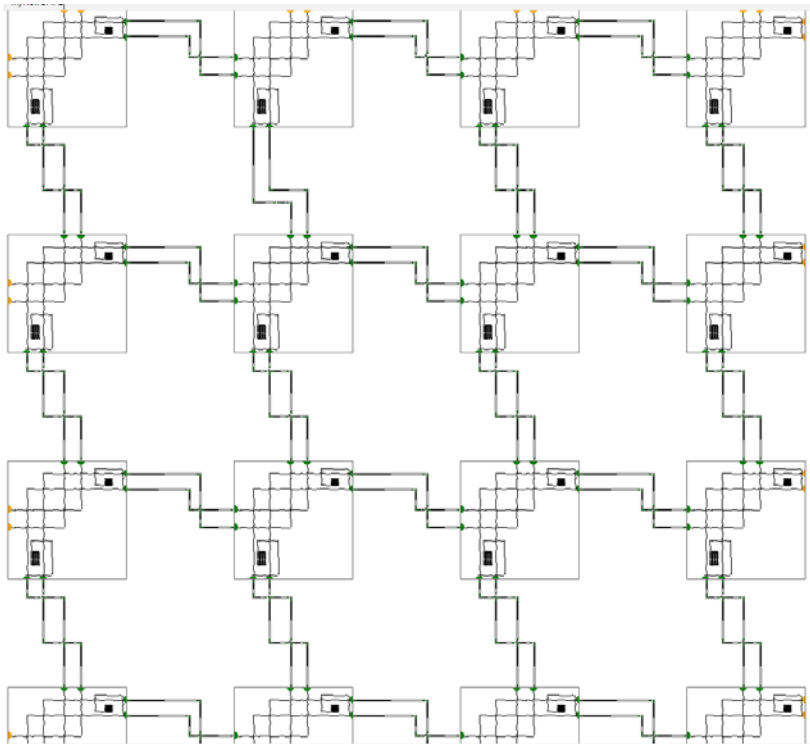


However, .1 dB insertion loss per vertical coupling [Sun et al. 2008]

Insertion Loss Analysis



- Worst-case insertion loss for a photonic mesh

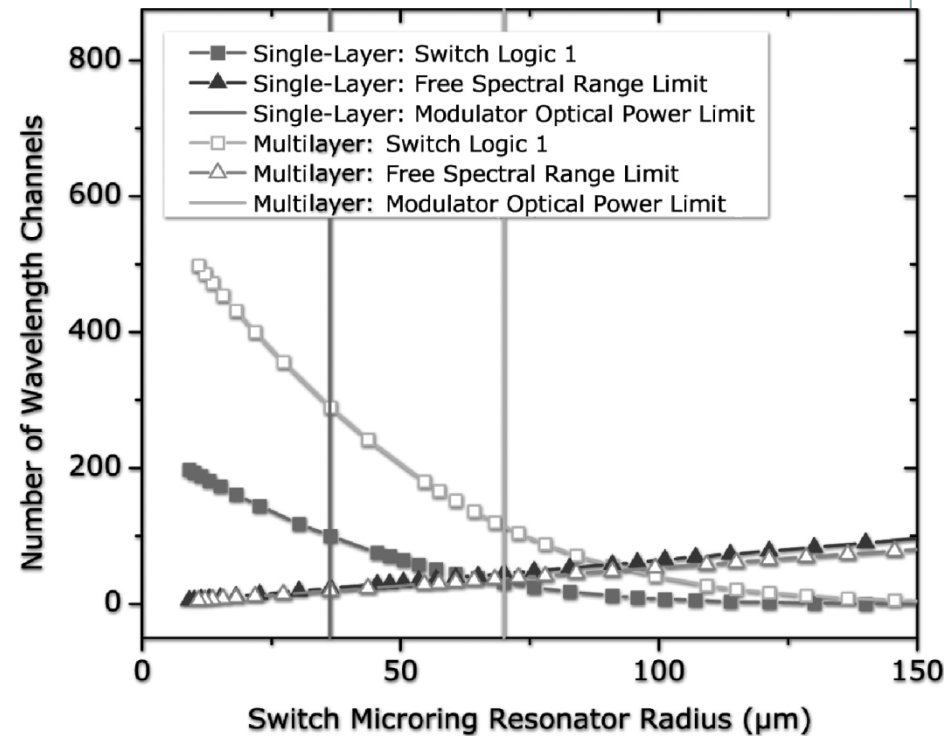
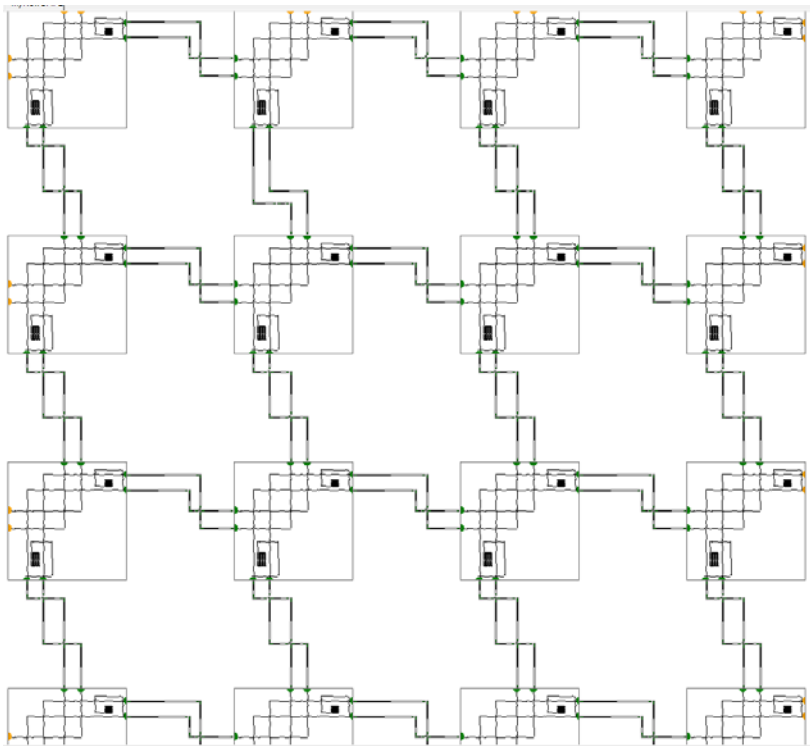


[Biberman et al. 2011]

Insertion Loss Analysis



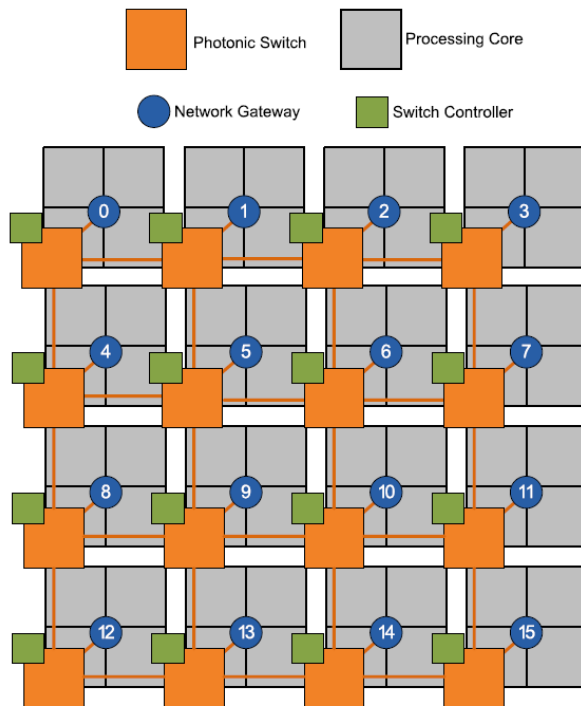
- Worst-case insertion loss for a photonic mesh



[Biberman et al. 2011]

Photonic TDM NoC Architecture

- Mesh topology
- No electronic links, other than TDM clock distribution



TIME

Time slot 1

Time slot 2

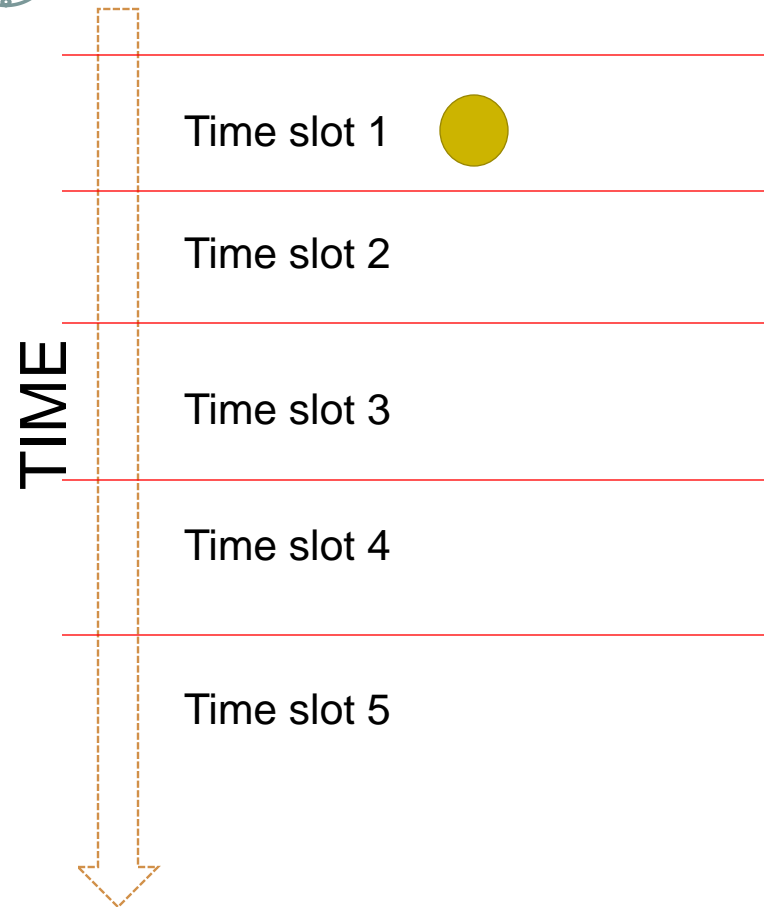
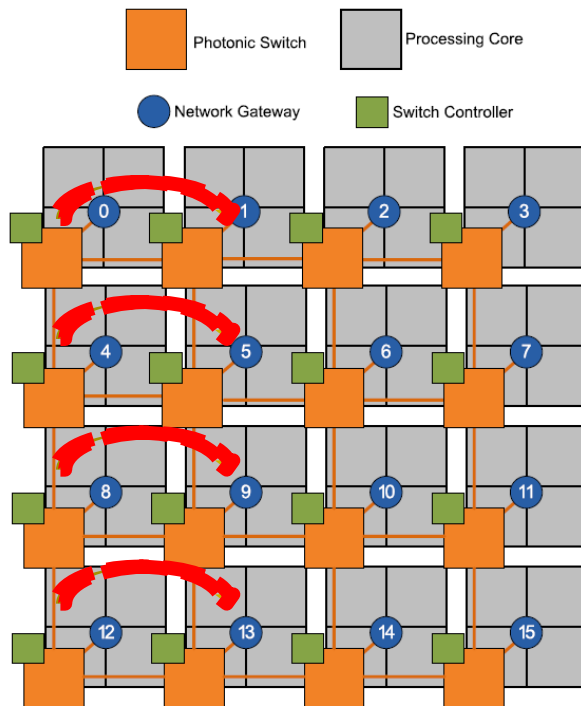
Time slot 3

Time slot 4

Time slot 5

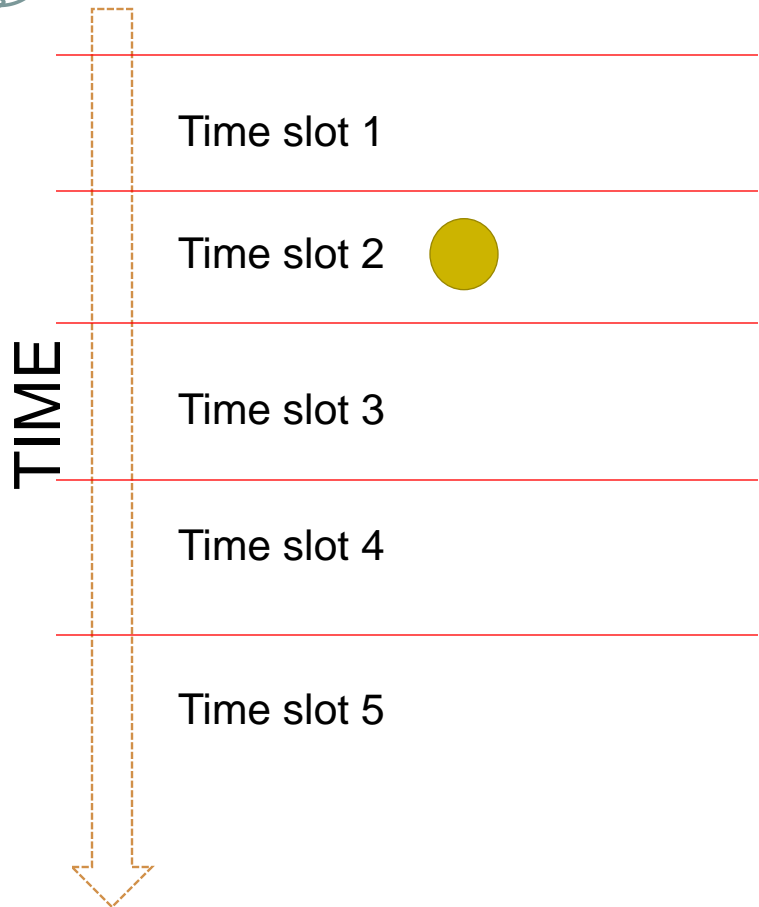
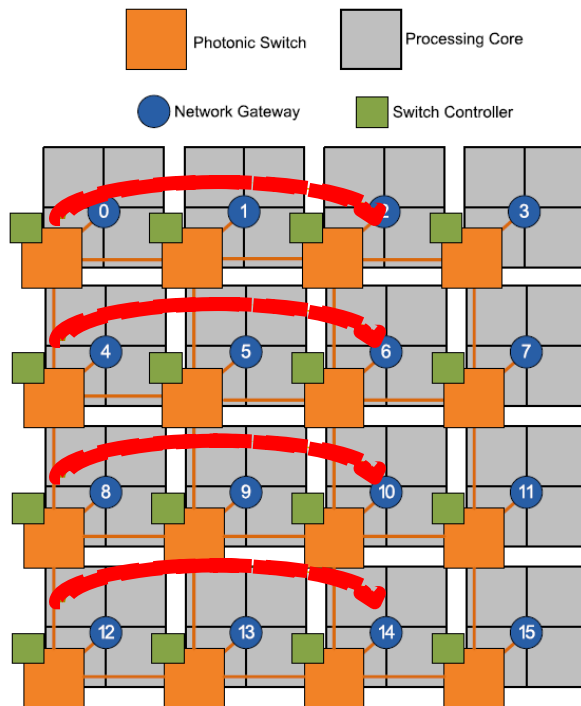
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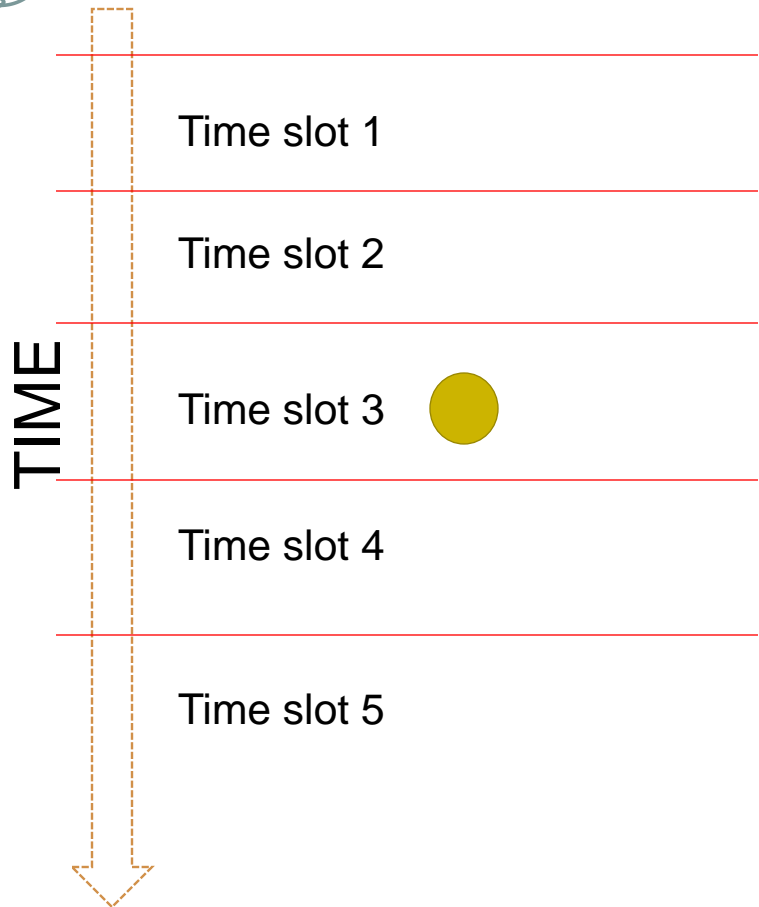
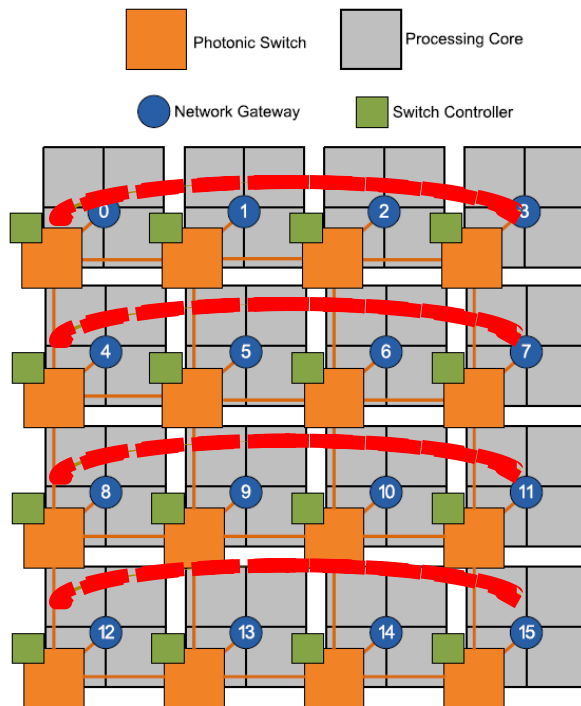
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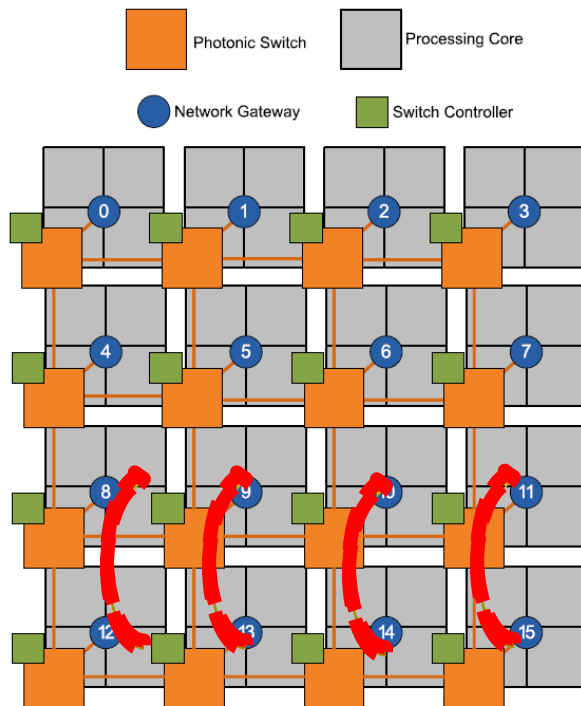
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TIME

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Time slot 2

Time slot 3

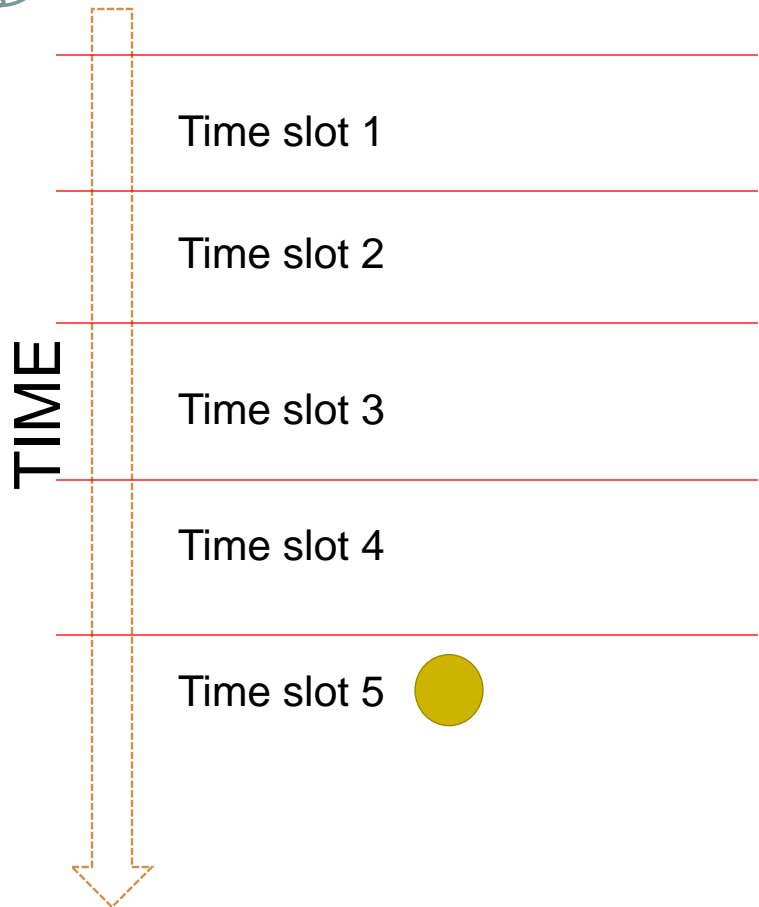
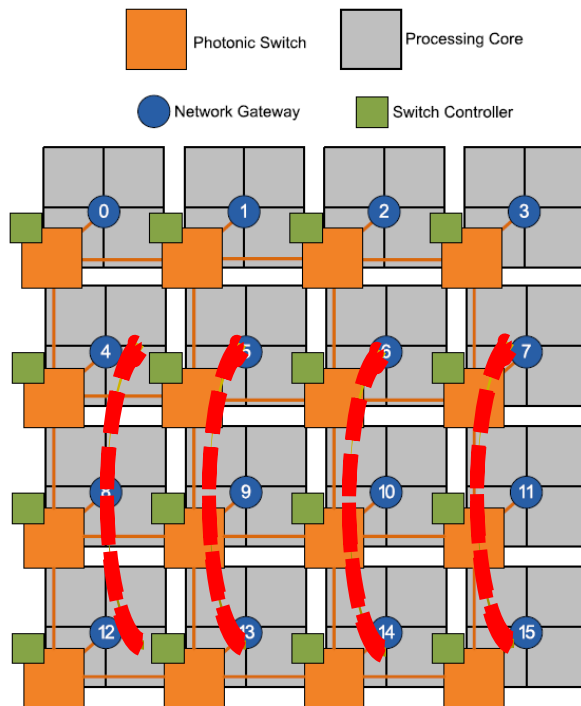
Time slot 4



Time slot 5

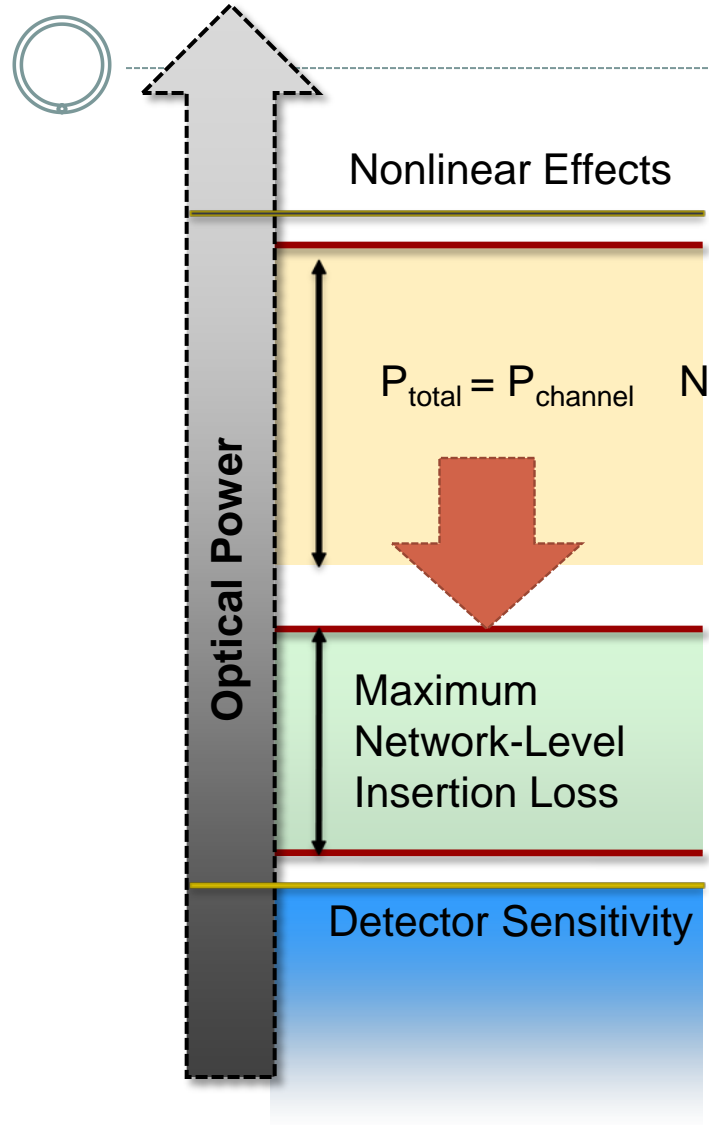
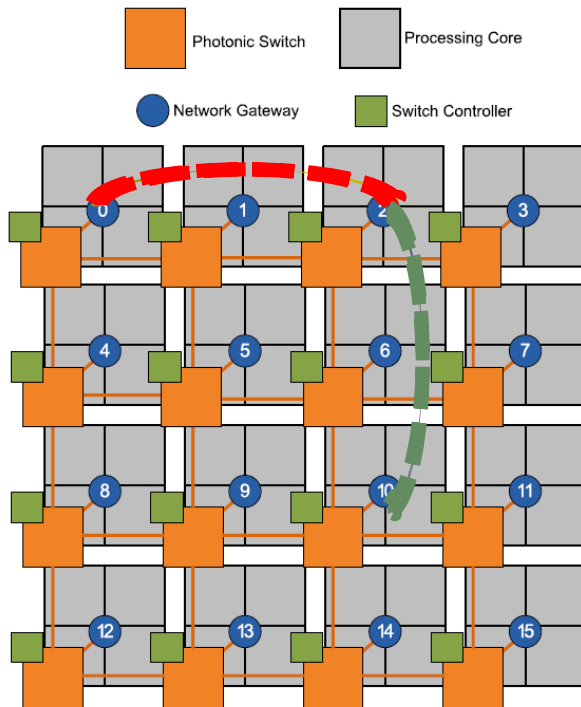
Photonic TDM NoC Architecture

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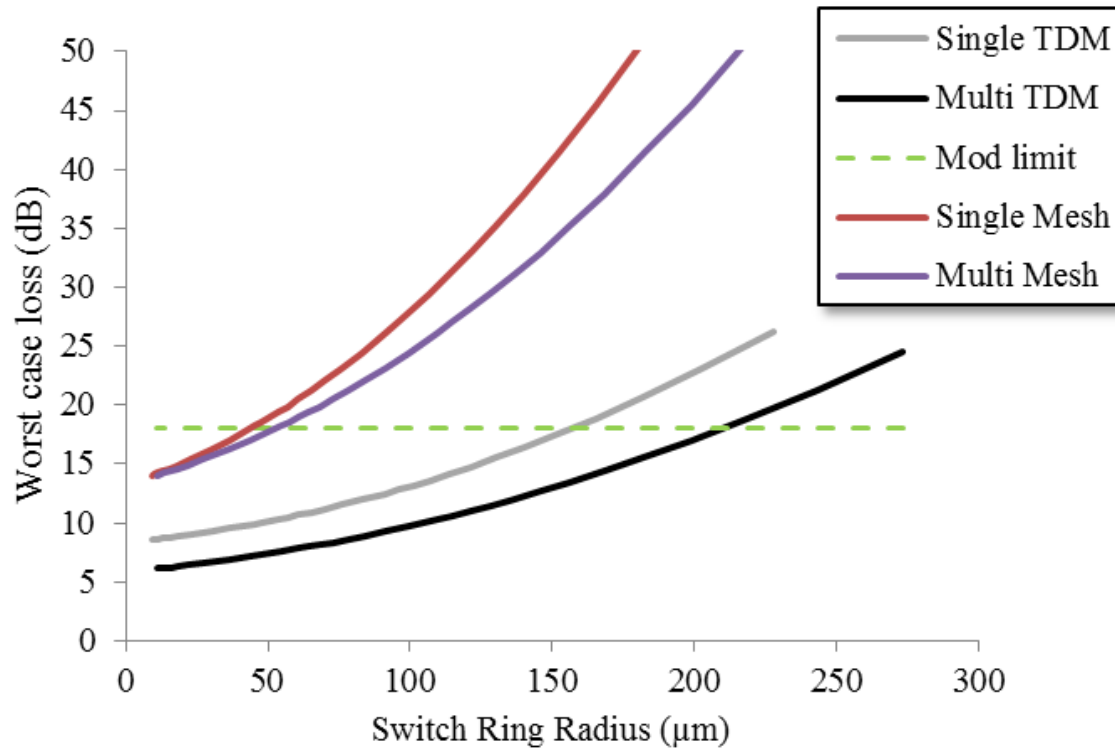


X-Y Buffering

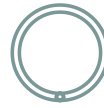
- Mesh topology
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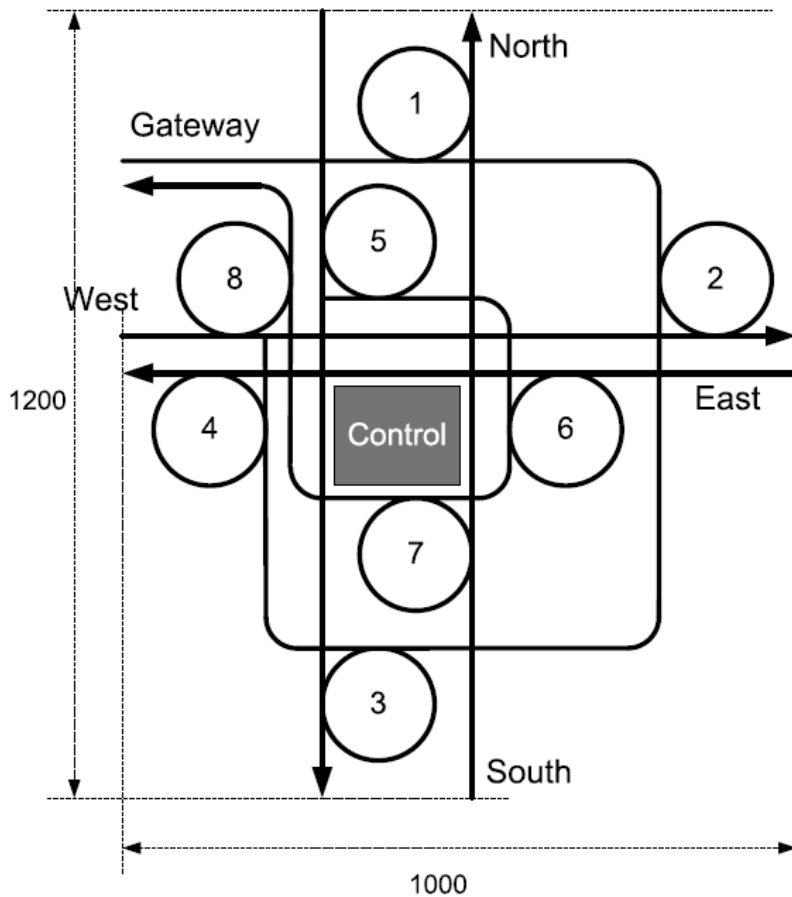
Photonic TDM vs. Photonic Circuit-Switched Insertion Loss



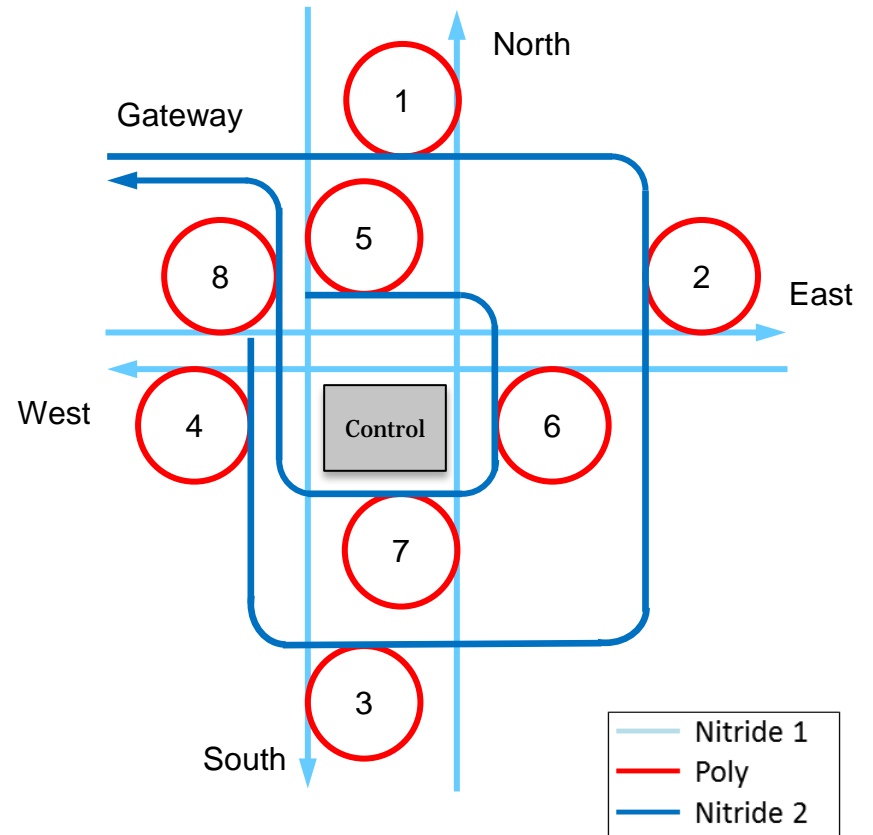
Single-Layer Switch vs. Multi-layer Switch



Single-layer TDM Switch



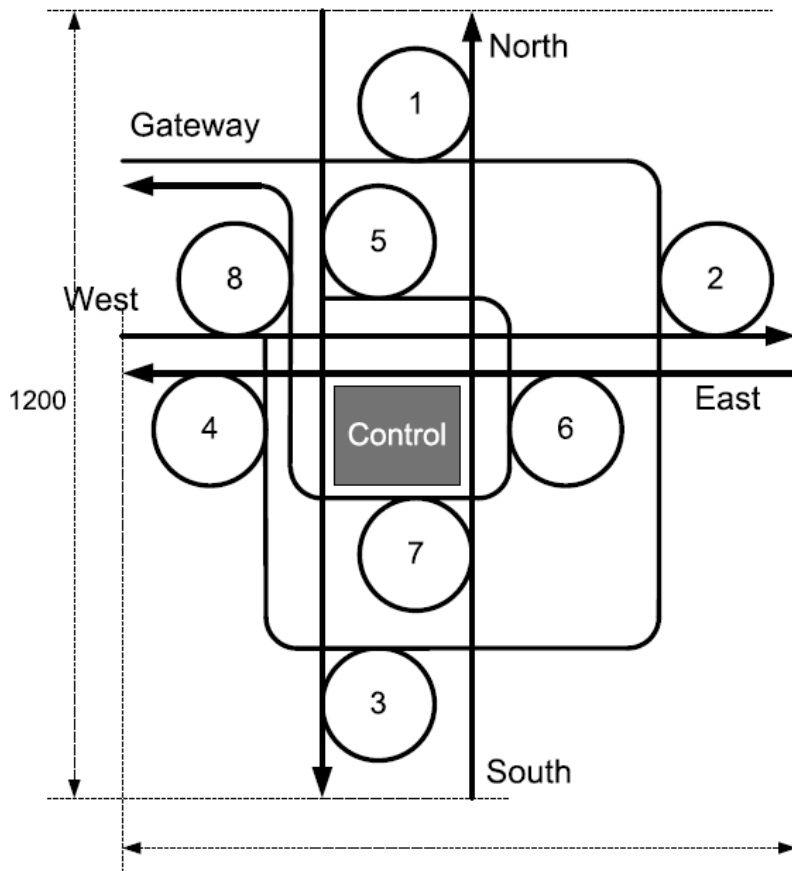
Multi-layer TDM Switch



Single-Layer Switch vs. Multi-layer Switch

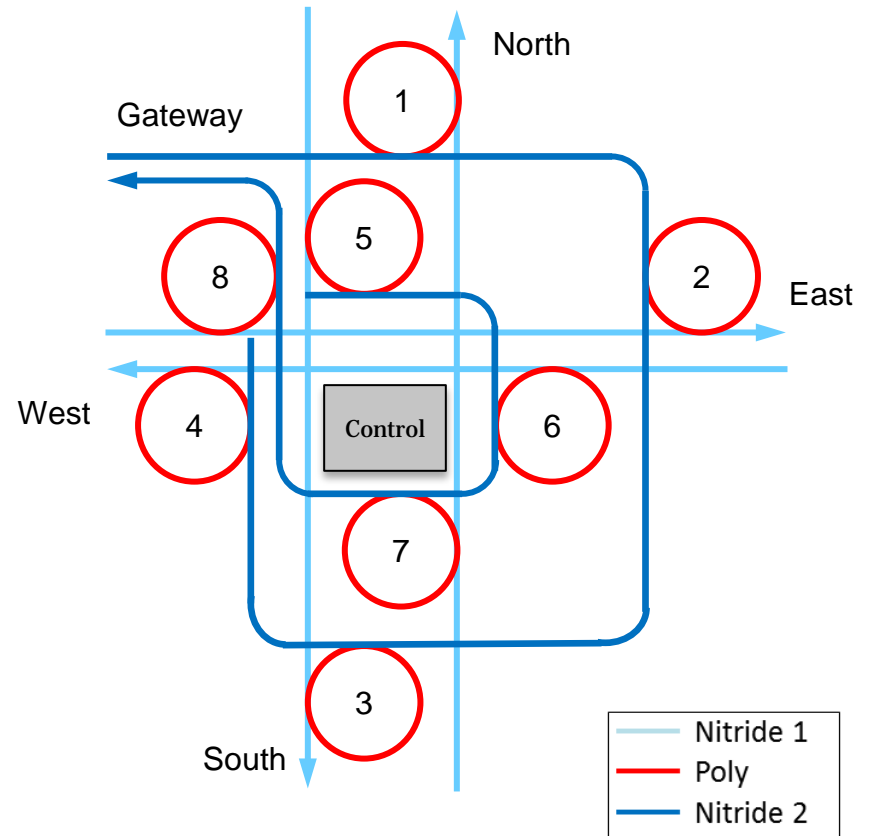


Single-layer TDM Switch



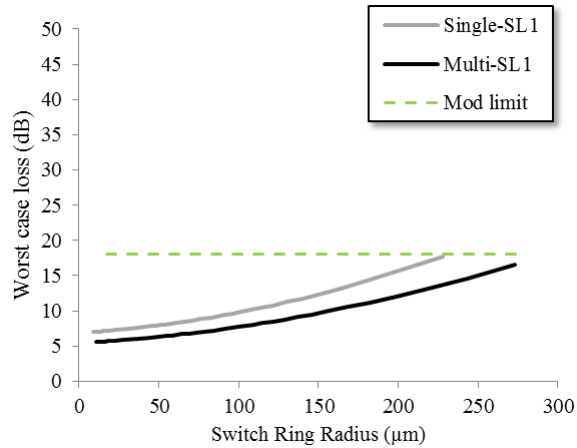
18 crossings

Multi-layer TDM Switch

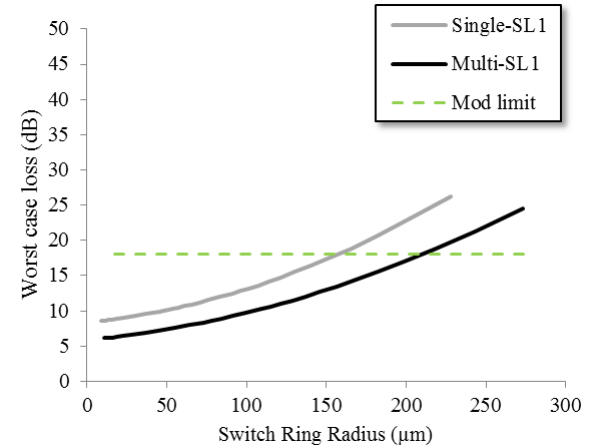


4 crossings

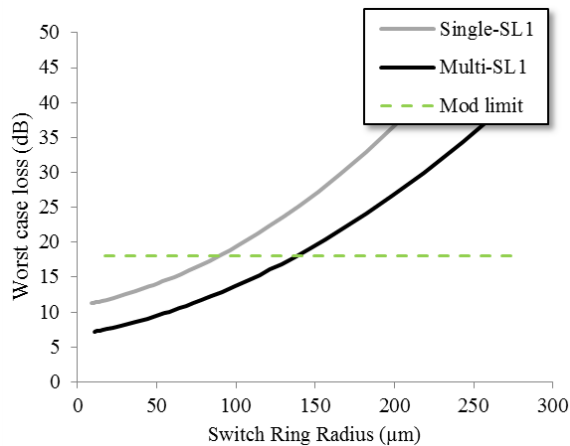
TDM Network Insertion Loss Analysis



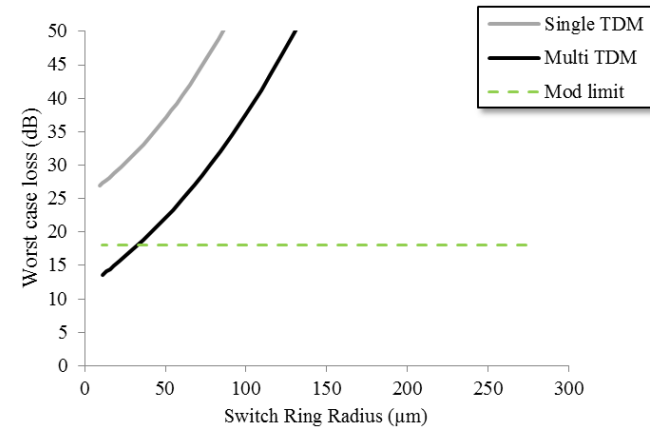
4x4 Network



8x8 Network

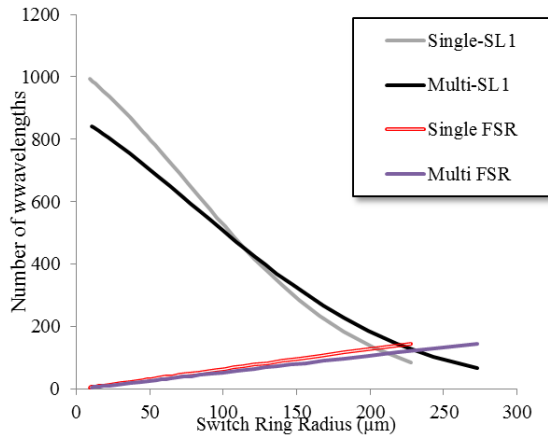


16x16 Network

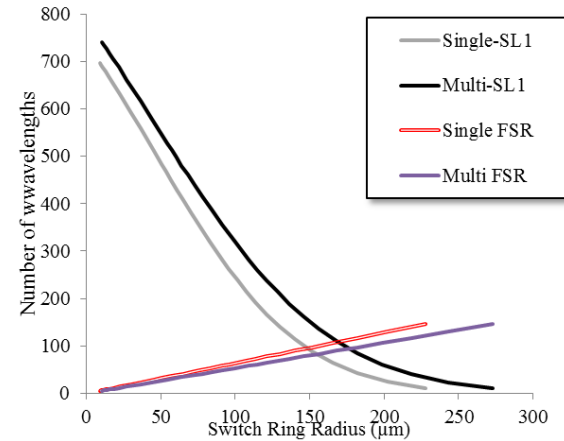


64x64 Network

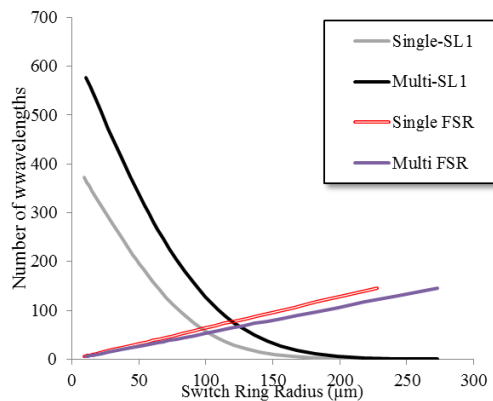
Maximum Bandwidth (# of Wavelengths)



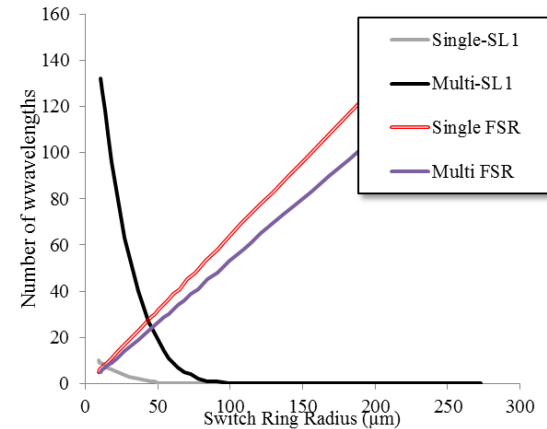
4x4 Network



8x8 Network

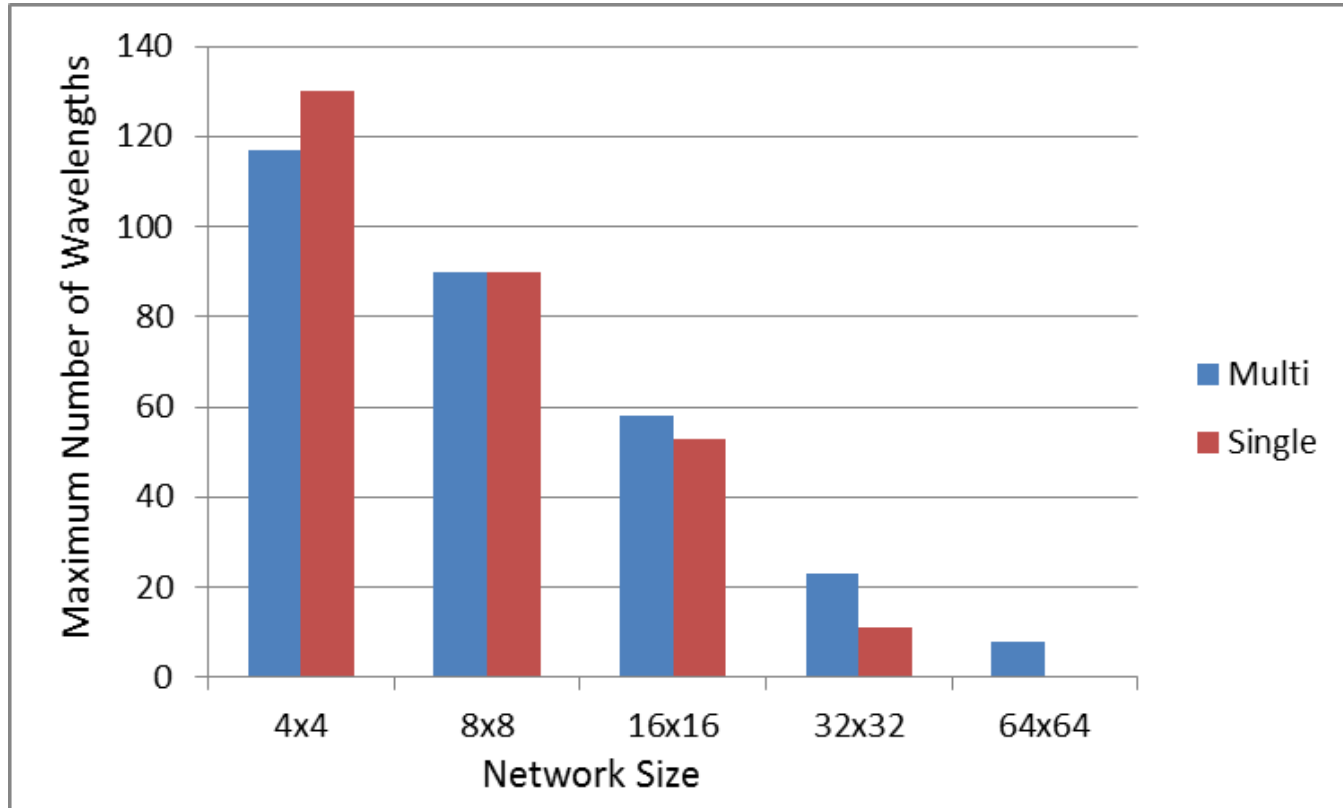


16x16 Network



64x64 Network

Summary of Results



Conclusions



- **Poly-Silicon and Silicon Nitride in conjunction are a good choice of materials for photonic interconnection networks**
 - Low-loss
 - = more wavelengths = higher bandwidth
- **We've shown that our best network, when at large scale, can be improved with a multi-layer implementation**
- **Future work: We expect the elimination of waveguide crossings to significantly reduce crosstalk across a wide variety of network architectures**